



1763

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PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/611,037  
Applicant: Kuthi, et al.  
Filed: July 6, 2000  
Title: METHOD FOR IMPLEMENTING A SEMICONDUCTOR PROCESS CHAMBER ELECTRODE

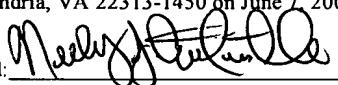
TC/A.U. : 1763  
Examiner : Alejandro Mulero, L.

Atty. Docket No. : LAM1P077A  
Date: June 7, 2004

**Duplicate for fee processing**

Commissioner for Patents  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING**  
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on June 7, 2004.

Signed:   
Neely J. Entwistle

Sir:

Transmitted herewith is an amendment in the above-identified application.

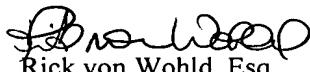
The fee has been calculated as shown below.

	Claims Remaining After <u>Amendment</u>	Highest Previously Paid For	Present <u>Extra</u>	SMALL ENTITY <u>RATE FEE</u>	OR	LARGE ENTITY <u>RATE FEE</u>
TOTAL CLAIMS	16 -	20	0	X09 = \$	OR	X18 = \$0
INDEP CLAIMS	03 -	03	0	X40 = \$	OR	X80 = \$0
[ ] Multiple Dependent Claim Present and Fee Not Previously Paid				\$135		\$270
			TOTAL	\$ _____		\$ _____

Applicant believes that no Extension of Time is required; however, if it is determined that such an extension is required, Applicant hereby petitions that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805

If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM1P077A). A copy of this sheet is enclosed.

Respectfully submitted,  
MARTINE & PENILLA, LLP

  
Rick von Wohld, Esq.  
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Signed: *Neely J. Entwistle*

Neely J. Entwistle

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

Applicants submit this paper in response to the Notice of Non-Compliant Amendment dated May 20, 2004. The period for response extends to June 20, 2004. Please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Argument begins on page 8 of this paper.